

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re: **Eun-ae Chung; Ki-hyun Hwang; Jung-hwan Oh; Hyo-jung Kim; Seok-woo Nam; Won-sik Shin; U-in Chung; Young-sun Kim; Hee-seok Kim; Beom-jun Jin**

For: **CAPACITORS OF SEMICONDUCTOR DEVICES INCLUDING SILICON-GERMANIUM AND METALLIC ELECTRODES AND METHODS OF FABRICATING THE SAME**

April 13, 2004

Mail Box Patent Application
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

APPLICATION FILED UNDER 37 CFR 1.41(c)

Sir:

The above-identified application is being filed on behalf of the inventors, all residents of the Republic of Korea, under the provisions of 37 CFR 1.41(c). A Declaration and Power of Attorney from the inventors will follow, 37 CFR 1.63.

Respectfully submitted,



Mitchell S. Bigel
Registration No. 29,614

Myers Bigel Sibley & Sajovec, P.A.
P. O. Box 37428, Raleigh, NC 27627
Telephone: (919) 854-1400
Facsimile: (919) 854-1401
Customer No. 20792

CERTIFICATE OF EXPRESS MAILING

Express Mail Label No. EV 381441370 US
Date of Deposit: April 13, 2004

I hereby certify that this correspondence is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under 37 CFR § 1.10 on the date indicated above and is addressed to: Mail Stop PATENT APPLICATION, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.



Susan E. Freedman
Date of Signature: April 13, 2004